

IDS Form PTO/SB/08: Substitute for form 1449A/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>				<i>Application Number</i>	10/529,949
				<i>Filing Date</i>	April 1, 2005
				<i>First Named Inventor</i>	Takayoshi Mamine
				<i>Art Unit</i>	1637
				<i>Examiner Name</i>	Babic, Christopher M.
<i>Sheet</i>	1	of	1	<i>Attorney Docket Number</i>	09812.0391



U.S. PATENTS AND PUBLISHED U.S. PATENT APPLICATIONS					
Examiner Initials	Cite No.	Document Number Number-Kind Code ² (if known)	Issue or Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		US-			
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Note: Copies of the U.S. Patent Documents are not Required in IDS filed after October 21, 2004

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No.	Foreign Patent Document Country Code ³ Number ⁴ Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Translation ⁶
		JP 2002-250726	09-06-2002	Toray Ind. Inc.		Abstract
		JP 2000-060554	02-29-2000	Hitachi Ltd.		Abstract
		JP 4-505763	10-08-1992	Affymax Technologies NV		
		WO 90/15070	12-13-1990	Affymax Technologies NV		
		JP 10-503841	04-07-1998	The Board of Trustees of the Leland Stanford Junior University		
		WO 95/35505	12-28-1995	The Board of Trustees of the Leland Stanford Junior University		
		WO 01/33226	05-10-2001	IBM Corp.		

NON PATENT LITERATURE DOCUMENTS				
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Translation ⁸	
		SEIICHI SUZUKI et al., "Quantitative Analysis of DNA Orientation in Stationary AC Electric Fields Using Fluorescence Anisotropy," IEEE Transactions on Industry Applications, Vol. 34, No. 1, Pages 75-83.		
		MASAO WASHIZU et al., "Electrostatic Manipulation of DNA in Microfabricated Structures," IEEE Transactions on Industry Applications, Vol. 26, No. 6, Pages 1165-1172.		

<i>Examiner Signature</i>	/Christopher Babic/	<i>Date Considered</i>	06/01/2008
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /CB/